

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L1 | 2 | ("5911619").PN. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 14:14 |
| L2 | 178 | ECMD or ((electrochemical adj mechanical) adj deposit\$3) or (electrochemical-mechanical adj deposit\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 14:24 |
| L3 | 2 | ("6176992").PN. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:08 |
| L4 | 328 | (205/222).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:14 |
| L5 | 176 | (205/221).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:08 |
| L6 | 455 | (205/157).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:08 |
| L7 | 518 | (205/123).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:09 |
| L8 | 269 | (205/640).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:09 |
| L10 | 679 | (204/225).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:09 |

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| L11 | 815 | (204/224M).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:09 |
| L12 | 66 | (I11 or I10 or I8 or I7 or I6 or I5 or I4) and (ECMD or ECME or (electrochemical adj mechanical) or (electrochemical-mehanical)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:11 |
| L13 | 260 | (basol and bulent).in. or (uzoh and cyprian).in. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 15:14 |
| S1 | 2176 | electrochemical adj deposition | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 17:50 |
| S2 | 313 | (electrochemical adj2 deposition).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:18 |
| S3 | 18 | (planarity and detection).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 17:57 |
| S4 | 10273 | (deposit\$3 and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:00 |
| S5 | 201 | (deposit\$3 and detect\$3 and planar\$5 and light).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:12 |
| S6 | 35 | (deposit\$3 and detect\$3 and planar\$5 and light).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:02 |
| S7 | 233 | ((deposit\$3 and detect\$3 and planar\$5 and light).clm.) or ((deposit\$3 and detect\$3 and planar\$5 and light).ab.) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:01 |

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| S8 | 313 | (deposit\$3 and detect\$3 and conduct\$3 and light).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:03 |
| S9 | 489 | (deposit\$3 and detect\$3 and conduct\$3 and light).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:03 |
| S10 | 787 | ((deposit\$3 and detect\$3 and conduct\$3 and light).ab.) or ((deposit\$3 and detect\$3 and conduct\$3 and light).clm.) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:03 |
| S11 | 87 | (deposit\$3 and sensor and planar\$5 and light).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:29 |
| S12 | 431 | (deposit\$3 and reflect\$3 and planar\$5 and light).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:06 |
| S13 | 61 | (electrochemical and deposition and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/14 19:35 |
| S14 | 7 | (electrochemical and metalliz\$5 and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:09 |
| S15 | 453 | (metalliz\$5 and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:09 |
| S16 | 126 | (metalliz\$5 and detect\$3 and light).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:10 |
| S17 | 9 | (metalliz\$5 and detect\$3 and planariz\$5).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:10 |

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| S18 | 628 | (deposit\$3 and detect\$3 and planar\$5).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:13 |
| S19 | 105 | (205/81).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:18 |
| S20 | 129 | (205/82).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:26 |
| S21 | 46 | (205/87).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:19 |
| S22 | 74 | (205/91).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:19 |
| S23 | 23 | (205/92).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:19 |
| S24 | 1105 | (216/13).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:20 |
| S25 | 1204 | (216/18).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:21 |

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| S26 | 220 | (216/37).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:21 |
| S27 | 357 | (216/38).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:22 |
| S28 | 381 | (216/88).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:22 |
| S29 | 24 | ((205/82).CCLS.) and light | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 14:04 |
| S30 | 3 | ((205/82).CCLS.) and reflectivity | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:28 |
| S31 | 16 | ((205/82).CCLS.) and reflect\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:28 |
| S32 | 24 | (electroplat\$3 and light and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:29 |
| S33 | 38 | (electroplat\$3 and planar\$5 and light).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/10 18:30 |
| S34 | 334 | (438/697).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 14:01 |
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| S35 | 1658 | (438/692).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 13:59 |
| S36 | 20 | ((438/697).CCLS.) and detect\$3 and light | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 14:02 |
| S37 | 1981 | (chemical\$1mechanical or (chemical adj mechanical)) and electroplat\$3 and planar\$7 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 14:10 |
| S38 | 646 | (chemical\$1mechanical or (chemical adj mechanical)) and electroplat\$3 and planar\$7 and light | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 14:10 |
| S39 | 9 | ((205/82).CCLS.) and beam | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 16:50 |
| S40 | 52 | (electrodeposit\$3 and detect\$3). clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 17:26 |
| S41 | 3 | (electrodeposit\$3 and detect\$3 and planar\$7).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 18:35 |
| S42 | 17 | (electrodeposit\$3 and detect\$3 and (light or laser or radiat\$3)). clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 18:37 |
| S43 | 31 | ((chemical adj mechanical) and detect\$3 and (light or laser or radiat\$3) and (end-point or (end adj point))).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 18:38 |
| S44 | 2 | ("4944836").PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/12 18:41 |

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| S45 | 345 | electrochemical adj mechanical | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/14 19:53 |
| S46 | 10 | (electrochemical adj mechanical) and ((end adj point) or end-point) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 19:02 |
| S47 | 129 | (electrochemical adj mechanical) and (detect\$3 or optical or end\$1point or light or inspect\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/14 19:49 |
| S48 | 114 | (electrochemical adj mechanical) and (planar\$7) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 14:50 |
| S49 | 30 | (electrochemical adj mechanical) and (planar\$7) and (light or laser) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/14 19:54 |
| S50 | 56 | electrochemical adj mechanical adj deposit\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 15:03 |
| S51 | 7 | (electrochemical adj mechanical adj deposit\$3) and (light or laser) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 14:37 |
| S52 | 7 | (electrochemical adj mechanical adj deposit\$3) and (light or laser or optical) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 14:38 |
| S53 | 2 | ("6176992").PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 14:51 |
| S54 | 8 | electro-chemical adj mechanical adj deposit\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 14:51 |

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| S55 | 63 | electro\$1chemical adj mechanical adj deposit\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 15:04 |
| S56 | 3 | electro\$1chemical\$1mechanical adj deposit\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 15:04 |
| S57 | 19 | electro\$1chemical adj mechanical adj (deposit\$3 and etch\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/15 15:04 |
| S58 | 158 | ((mechanical adj (planariz\$5 or polish\$3)) and ((end adj point) or end-point) and (light or laser) and conductor | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 16:52 |
| S59 | 427 | ((copper or conductor) near3 (CMP or (chemical adj mechanical))).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:04 |
| S60 | 11 | ((copper or conductor) and (CMP or (chemical adj mechanical)) and (end-point or endpoint)).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:05 |
| S61 | 30 | ((copper or conductor) and (CMP or (chemical adj mechanical)) and (end-point or endpoint)).dm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:07 |
| S62 | 21 | (copper adj CMP).ti. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:08 |
| S63 | 20 | (copper and CMP and (light or laser)).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:10 |
| S64 | 310 | copper and CMP and (light or laser) and detect\$3 and (end\$1point or endpoint) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:52 |

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| S65 | 147 | CMP same (light or laser) same detect\$3 same (end\$1point or endpoint) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:14 |
| S66 | 4 | (conduct\$3 and CMP and (laser) and detect\$3).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:53 |
| S67 | 23 | (conduct\$3 and planar\$7 and (laser) and detect\$3).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 13:54 |
| S68 | 603 | (planar\$7 and (laser) and detect\$3).ab. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 14:03 |
| S69 | 4 | ((("5413941") or ("4939370"))).PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/29 19:10 |
| S70 | 11 | "3737489".URPN. | USPAT | OR | OFF | 2003/11/16 14:04 |
| S71 | 4 | ("5131752" "5209813" "5240552" "5271796").PN. | USPAT | OR | OFF | 2003/11/16 14:04 |
| S72 | 131 | "5413941".URPN. | USPAT | OR | OFF | 2003/11/16 14:06 |
| S73 | 0 | "6576553".URPN. | USPAT | OR | OFF | 2003/11/16 14:12 |
| S74 | 25 | ("5069002" "5225034" "5234540" "5240522" "5242524" "5275974" "5314843" "5376483" "5407526" "5413941" "5439553" "5576126" "5637185" "5685951" "5688364" "5763306" "5767018" "5783495" "6037213" "6103456" "6107191" "6114235" "6200875" "6249019" "6458689" "2001/0014498").PN. | USPAT | OR | OFF | 2003/11/16 14:12 |
| S75 | 100 | (endpoint or end\$1point).ti. and laser and ((chemical adj mechanical) or chemical-mechanical) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/31 12:19 |

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| S76 | 79 | (156/345.13).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 16:21 |
| S77 | 48 | ((156/345.13).CCLS.) and conduct\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 16:22 |
| S78 | 22 | ((156/345.13).CCLS.) and laser | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 16:34 |
| S79 | 14 | ((("5413941") or ("6402925") or ("6176992") or ("6352623") or ("5807165") or ("5266446") or ("4939370"))).PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2003/11/16 16:35 |
| S80 | 2 | ("6179691").PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/29 19:11 |
| S81 | 14 | ((electrochemical adj2 deposition) and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/31 12:15 |
| S82 | 383 | detect\$3 and ((chemical adj mechanical) or chemical-mechanical) and (barrier adj layer) and (beam or laser) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 10:13 |
| S83 | 296 | detect\$3 and ((chemical adj mechanical) or chemical-mechanical) and (barrier adj layer) and (beam or laser) and copper | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/31 12:22 |
| S84 | 134 | detect\$3 and ((chemical adj mechanical) or chemical-mechanical) and (barrier adj layer) and (beam or laser) and copper and intensity | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/31 12:26 |

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| S85 | 21 | detect\$3 and ((chemical adj mechanical) or chemical-mechanical) and (barrier adj layer) and (beam or laser) and (intensity with increas\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/03/31 12:27 |
| S86 | 825 | ((mechanical adj planariz\$5) and ((end adj point) or end-point or detect\$3) and (light or laser or optical) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 16:54 |
| S87 | 55 | ((mechanical adj planariz\$5) and ((end adj point) or end-point or detect\$3) and (light or laser or optical)).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 16:54 |
| S88 | 17 | (electrodeposit\$3 and (optical or laser or light) and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 17:27 |
| S89 | 5 | (electro-deposit\$3 and (optical or laser or light) and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 17:27 |
| S90 | 3 | ((electrolytic adj deposit\$3) and (optical or laser or light) and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 17:28 |
| S91 | 4 | ((electrochemical adj deposit\$3) and (optical or laser or light) and detect\$3).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2004/08/19 17:28 |
| S92 | 269045 | detect\$3 near2 (light or laser or optical\$2) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:23 |
| S93 | 2941 | S92 and (CMP or chemical-mechanical or (chemical adj mechanical)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 11:20 |
| S94 | 1245 | S93 and (intensity with (light or beam)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 10:55 |

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| S95 | 390 | S92 and ((CMP or chemical-mechanical or (chemical adj mechanical)) with (conductor or copper or aluminum)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/28 14:19 |
| S97 | 136 | S95 and (intensity with (light or beam)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 10:56 |
| S98 | 107 | (endpoint adj detect\$3) with (cvd or deposition) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 11:40 |
| S99 | 89 | S98 and (optical\$2 or laser or light) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 11:22 |
| S10 0 | 160 | (endpoint adj detect\$3) with (cvd or deposit\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:17 |
| S10 1 | 1328 | (118/712).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:18 |
| S10 2 | 203 | S101 and (detect\$3 near2 (light or laser or optical\$2)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:34 |
| S10 3 | 1490 | deposit\$3 with (detect\$3 near2 (light or laser or optical\$2)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:46 |
| S10 4 | 236 | (deposit\$3 with (detect\$3 near2 (light or laser or optical\$2))).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:34 |
| S10 5 | 30 | (deposit\$3 with (copper or aluminum or metal\$3 or conduct\$3) with (detect\$3 near2 (light or laser or optical\$2))).clm. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/04/05 12:35 |